



520.35237VX3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. KAJI, et al.
Application No.: 10/052,538
Filed: January 23, 2002
For: PLASMA PROCESSING APPARATUS PROCESSING METHOD
Art Unit: 1763
Examiner: A. M. Crowell

AMENDMENT AND STATEMENT OF SUMMARY OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 25, 2005

Sir:

In response to the Office Action dated September 21, 2004, the period of response for which extension is requested by the attached Petition for Extension of Time, please amend the above-identified application as listed below and set forth on the following pages:

Amendments to the Claims and

Remarks are included following the amendments.